

Notice of References Cited	Application/Control No. 10/687,643	Applicant(s)/Patent Under Reexamination MINO, TETSUYA	
	Examiner Paul D. Kim	Art Unit 3729	Page 1 of 1

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	B	US-5,802,700	09-1998	Chen et al.	29/603.14
	C	US-5,438,747	08-1995	Krounbi et al.	29/603.16
	D	US-5,285,340	02-1994	Ju et al.	360/119
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	N	JP 60074107 A	04-1985	Japan	KOBAYASHI et al.	G11B 05/235
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	U	"Writing performance of narrow gap heads made with sputtered laminated FeN materials on 3800 Oe coercivity media"; Hu, H.L.; Vo, L.; Nguyen, T.; Robertson, N.; Re, M.; Jahnes, C.; Magnetics, IEEE Transactions on Volume 30; Nov 1994 Pages:3870-3872.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.